

	Type	L #	Hits	Search Text	DBs	Time Stamp
1	BRS	L1	236	dielectric near layer and silica near layer	USPAT; EPO; JPO; DERWEN T	2003/03/05 23:39
2	BRS	L4	27	dielectric and silica and LPD and substrate	USPAT; EPO; JPO; DERWEN T	2003/03/05 23:39